

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention

CHEMICAL MECHANICAL POLISHING PROCESS

Application Number :

Confirmation Number:

First Named Applicant: Chia-Lin Hsu

Attorney Docket Number: NAUP0633USA

Art Unit:

Examiner:

Search string: (6573173).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6573173	2003-06-03	Farkas, ET AL.			

Signature

Examiner Name	Date